

L Number	Hits	Search Text	DB	Time stamp
104	1	(photonic with resonator) same (silica with silicon)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:00
105	91	(photonic or microphotonic) same (silica with silicon)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:07
106	553	(photonic or microphotonic) same (silica or (silicon near1 dioxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:07
107	14	(photonic or microphotonic) same (silica or (silicon near1 dioxide)) same (stress\$3 or strain\$3 or deform\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:10
108	139	tun\$3 same (silica or (silicon near1 dioxide)) same (stress\$3 or strain\$3 or deform\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:20
109	2466	thermal same (silica or (silicon near1 dioxide)) same (stress\$3 or strain\$3 or deform\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:12
110	79	(thermal same (silica or (silicon near1 dioxide)) same (stress\$3 or strain\$3 or deform\$3)) and photonic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:12
111	1199	(silica or (silicon near1 dioxide)) same piezoelectric	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:20
112	195	((silica or (silicon near1 dioxide)) same piezoelectric) and tun\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:21
113	54	(((silica or (silicon near1 dioxide)) same piezoelectric) and tun\$3) and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 17:21
-	7	wong-chee-w\$.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:40
-	23	barbastathis-george.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:41
-	7	kim-sang-gook.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:41

	30	wong-chee-w\$.in. or barbastathis-george.in. or kim-sang-gook.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:43
	9389	385/122,129-132,1,2,4,8,9,14,39,40.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:44
	171	385/122,129-132,1,2,4,8,9,14,39,40.ccls. and (photonic near1 crystal)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:45
	86	(385/122,129-132,1,2,4,8,9,14,39,40.ccls. and (photonic near1 crystal)) and (silica or (silicon near1 dioxide) or sio\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:58
	27	((385/122,129-132,1,2,4,8,9,14,39,40.ccls. and (photonic near1 crystal)) and (silica or (silicon near1 dioxide) or sio\$5)) and (stress\$3 or deform\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:55
	29	((385/122,129-132,1,2,4,8,9,14,39,40.ccls. and (photonic near1 crystal)) and (silica or (silicon near1 dioxide) or sio\$5)) and (stress\$3 or deform\$3 or strain\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 10:58
	95	(385/122,129-132,1,2,4,8,9,14,39,40.ccls. and (photonic near1 crystal)) and (silica or (silicon near1 \$2oxide) or sio\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 11:07
	31	((385/122,129-132,1,2,4,8,9,14,39,40.ccls. and (photonic near1 crystal)) and (silica or (silicon near1 \$2oxide) or sio\$5)) and (stress\$3 or deform\$3 or strain\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 11:07
	126	tun\$3 with waveguide\$1 same (stress\$3 or deform\$3 or strain\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 11:07
	79	(tun\$3 with waveguide\$1 same (stress\$3 or deform\$3 or strain\$3)) and (silica or (silicon near1 \$2oxide) or sio\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 11:08
	21	((tun\$3 with waveguide\$1 same (stress\$3 or deform\$3 or strain\$3)) and (silica or (silicon near1 \$2oxide) or sio\$5)) and photonic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 12:27
	2	6222954.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 12:27
	2	6721475.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 14:31

	2	6751368.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 14:31
	1	6751368.pn. and photonic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:02
	1	microracetrack	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:03
	74	micro\$1ring near1 resonator	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:03
	4	(micro\$1ring near1 resonator) and oval	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:10
	103616	silicon near1 dioxide	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:45
	1085	(silicon near1 dioxide) and photonic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:45
	13	(silicon near1 dioxide) and microphotonic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 15:51
	383	silicon near1 base near1 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/07 16:59